

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2814
Serial No. : 09/362,808 Examiner : Shrinivas H. Rao
Filed : July 28, 1999 Conf. No. : 7320
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Please consider the references listed on the enclosed PTO-1449 form. Foreign patent documents and non-patent literature are enclosed.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
12	JAPAN 02-044769 – Full English Translation
13	JAPAN 04-358129 – Full English Translation

This statement is being filed before the receipt of a first Office Action on the merits following the filing of a request for continued examination. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 10/29/08



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